

Title (en)

LITHOGRAPHY PROCESS FOR THE ENCAPSULATION OF PATTERNED THIN FILM COATINGS

Title (de)

LITHOGRAFISCHES VERFAHREN ZUR VERKAPSELUNG VON GEMUSTERTEN DÜNNSCHICHTBESCHICHTUNGEN

Title (fr)

PROCÉDÉ DE LITHOGRAPHIE PERMETTANT L'ENCAPSULATION DE REVÊTEMENTS DE FILMS MINCES À MOTIFS

Publication

EP 3325689 A4 20190417 (EN)

Application

EP 16825231 A 20160715

Priority

- US 201562193174 P 20150716
- US 2016042419 W 20160715

IPC 8 full level

G03F 7/40 (2006.01); **H01L 21/027** (2006.01)

CPC (source: EP US)

G03F 7/168 (2013.01 - US); **G03F 7/40** (2013.01 - EP); **H01L 21/0272** (2013.01 - EP)

Citation (search report)

- [A] US 2006154412 A1 20060713 - BRODSKY COLIN J [US], et al
- [A] US 4202914 A 19800513 - HAVAS JANOS [US], et al
- [A] US 2009111061 A1 20090430 - CHAU FRANK HIN FAI [US], et al
- See references of WO 2017011723A1

Designated contracting state (EPC)

AL AT BE BG CH CY CZ DE DK EE ES FI FR GB GR HR HU IE IS IT LI LT LU LV MC MK MT NL NO PL PT RO RS SE SI SK SM TR

DOCDB simple family (publication)

EP 3325689 A1 20180530; EP 3325689 A4 20190417

DOCDB simple family (application)

EP 16825231 A 20160715